



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of:

FRANK LEONARD SCHADT, III ET AL.

CASE NO.: PE0612 US PCT

APPLICATION NO.: 09/807,298

GROUP ART UNIT: 1756

FILED: APRIL 9, 2001

EXAMINER: YVETTE M. CLARKE

FOR: PHOTORESISTS AND PROCESSES FOR MICROLITHOGRAPHY

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

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Sir:

In compliance with 37 CFR 1.97 and 1.98, Applicants bring to the attention of the U.S. Patent and Trademark Office information listed on the enclosed PTO/SB/08A and PTO/SB/08B. A copy of the information is also enclosed.

Should any fee be required in connection with the filing of this Information Disclosure Statement, please charge such fee to Deposit Account No. 04-1928 (E. I. du Pont de Nemours and Company).

Respectfully submitted,

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Date: 18 Mar 2003

Enclosures